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# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

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Complete if Known

Application Number	10/714,850
Confirmation Number	3707
Filing Date	November 18, 2003
First Named Inventor	Shinji IMAI
Art Unit	2878
Examiner Name	Shun K. Lee
Attorney Docket Number	Q78573

## **U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>2</sup> (if known)		
SL		US 4,272,477		06/09/1981	Hagedorn
SL		US 4,922,103		05/01/1990	Kawajiri et al.
SL		US 4,816,679		03/28/1989	Sunagawa et al.
SL		US 4,284,889		08/18/1981	Kato et al.
SL		US 4,346,406		08/24/1982	Kato et al.
SL		US 5,196,702	A	03/23/1993	Tsuji et al.
SL		US 6,192,105	B1	02/20/2001	Hunter et al.
		US 5,059,794		10/22/1991	Takahashi et al.
		US			

## **FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)			
SL	X	JP	55-12492		01/29/1980		
SL	X	JP	56-11395		02/04/1981		
SL	X	JP	60-111568		06/18/1985		
SL	X	JP	60-236354		11/25/1985		
SL	X	JP	63-259500		10/26/1988		
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SL	X	JP	55-50180		04/11/1980		
SL	X	JP	56-11348		02/04/1981		
		JP					

## **NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>6</sup>
SL	X	Patent Abstract JP 56011395 A February 4, 1981	
SL	X	Patent Abstract JP 63259500 A April 16, 1987	
SL	X	Patent Abstract DE 3151570 A July 7, 1983	
SL	X	"Radiographic Process Utilizing a Photoconductive Solid-State Imager", <u>Research Disclosure</u> , 772, Oct. 1992 by Joannes Van den Bogaert	

Examiner Signature

SL Lee

Date Considered

10/19/04

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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